

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAILEY et al.

Attorney Docket No.:

Application No.: 09/536,000

LAM1P130/P0566

Filed: March 27, 2000

Examiner:

ALEJANDRO MULERO, Luz L.

Title: METHOD AND APPARATUS FOR

Group: 1763

VARYING A MAGNETIC FIELD TO CONTROL

A VOLUME OF A PLASMA

CERTIFICATE OF EXPRESS MAILING

I hereby certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on September 10, 2002 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR §1.10, Mailing Label Number EL898648261US, addressed to: Commissioner for Patents, Box CPA, Washington, D.C. 20231.

Furchear

Sue Funchess

Commissioner for Patents Box CPA Washington, D.C. 20231

PRELIMINARY AMENDMENT C

Sir:

In response to the Office Action dated June 27, 2002, please amend the aboveidentified patent application as follows:

IN THE CLAIMS

Please cancel claims 12-18.

Please amend claims 1, 3, 8-11, 28 and 30 and add claims 37-41, as follows:

1. (Twice Amended) A plasma processing apparatus for processing a substrate, comprising:

a process chamber, defined at least in part by a top end and a bottom end and a wall extending between the top end and the bottom end, within which a plasma is ignited and sustained for said processing;

a magnetic array having a plurality of magnetic elements that are disposed around the periphery of said process chamber around the outside of said wall, said plurality of magnetic elements being configured to produce a magnetic field with an azimuthally symmetric radial